

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named

Inventor : Benjamin Y.H. Liu

Appln. No.: 10/769,011

Filed : January 30, 2004

For : HIGH-PERFORMANCE AND MULTI-LIQUID-PERCURSOR
VAPORIZATION IN SEMICONDUCTOR THIN
FILM DEPOSITION

Docket No.: M419.12-0043

Conf. No. 7978

Group Art Unit: 1792

Examiner: Bueker, Richard R.

REQUEST FOR APPROVAL OF FORMAL DRAWINGS

VIA ELECTRONIC FILING
DECEMBER 4, 2008

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

Enclosed are **EIGHT** (8) sheets of formal drawings for filing in the above-identified application.

Respectfully submitted,

WESTMAN, CHAMPLIN & KELLY, P.A.

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NEW:rkp